

<b>Notice of References Cited</b>	Application/Control No. 10/624,332	Applicant(s)/Patent Under Reexamination HEMBREE, DAVID R.	
	Examiner Cheung Lee	Art Unit 2812	Page 1 of 1

U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	A	US-5,552,635	09-1996	Kim et al.	257/706
	B	US-			
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	D	US-			
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	F	US-			
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FOREIGN PATENT DOCUMENTS

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NON-PATENT DOCUMENTS

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